

# Jacobian Structure of Coupled Electromagnetic Field and Lumped Circuit Models

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**Summary.** Motivated by the aim of an efficient coupled electromagnetic field and lumped circuit simulation, we show that one can form the model equations in such a way that the discretized equation system (using FIT method for spatial and BDF method for time discretization) has an exploitable Jacobian structure.

## 1 Electromagnetic Field Model

The electromagnetic fields can be described by the full-wave Maxwell's equations

$$\begin{aligned}\nabla \cdot \mathbf{D} &= \rho, & \nabla \times \mathbf{E} &= -\partial_t \mathbf{B} \\ \nabla \cdot \mathbf{B} &= 0, & \nabla \times \mathbf{H} &= \mathbf{J} + \partial_t \mathbf{D}\end{aligned}$$

equipped with the material laws

$$\mathbf{D} = \varepsilon \mathbf{E}, \quad \mathbf{H} = \nu \mathbf{B},$$

where  $\mathbf{D}$ ,  $\mathbf{E}$ ,  $\mathbf{B}$ ,  $\mathbf{H}$ ,  $\mathbf{J}$  and  $\rho$  are the displacement field, electric field, magnetic induction, magnetic field, free current density and charge density. The material dependent parameters  $\varepsilon$  and  $\mu$  are the permittivity and the magnetic permeability. The charge  $\rho$  and the current density  $\mathbf{J}$  can be described by the following model equations:

$$\rho = \begin{cases} 0 & \text{for metal and isolator} \\ q(n - p - N_D) & \text{for semiconductor} \end{cases} \quad (1)$$

and

$$\mathbf{J} = \begin{cases} \sigma \mathbf{E} & \text{for metal} \\ \mathbf{J}_n + \mathbf{J}_p & \text{for semiconductor} \\ 0 & \text{for isolator} \end{cases} \quad (2)$$

with the electron and hole current densities  $J_n$  and  $J_p$  as well as the electron and hole concentrations  $n$  and  $p$  satisfying

$$\partial_t n - \nabla \cdot \mathbf{J}_n + qR(n, p) = 0 \quad (3)$$

$$\partial_t p + \nabla \cdot \mathbf{J}_p + qR(n, p) = 0 \quad (4)$$

with

$$\mathbf{J}_n = qD_n \nabla n - q\mu_n n \mathbf{E}, \quad \mathbf{J}_p = qD_p \nabla p + q\mu_p p \mathbf{E}.$$

The material depending parameters  $N_D$ ,  $\sigma$ ,  $\mu_n$  and  $\mu_p$  describe the doping concentration, the conductivity, the mobility of electrons and the mobility of holes. The function  $R$  gives the recombination rate for electrons and holes. Finally,  $q$  is the elementary charge and  $D_n$ ,  $D_p$  are the diffusion coefficients.

Notice, the semiconductor current density model reflects the drift-diffusion model [9] and should be extended by an additional current density part caused by the self-induced Lorentz force in case of circuits with fast-transient signals, see [8].

To facilitate the coupling between the electromagnetic field simulation with a lumped circuit simulation, the Maxwell equations are written in potential form using the scalar potential  $\varphi$  and the vector potential  $\mathbf{A}$  [1, 2] satisfying

$$\mathbf{B} = \nabla \times \mathbf{A}, \quad \nabla \varphi = -\mathbf{E} - \partial_t \mathbf{A}. \quad (5)$$

The existence of these potentials follows from the Gauß' law  $\nabla \cdot \mathbf{B} = 0$  for magnetism and the Maxwell-Faraday law  $\nabla \times \mathbf{E} = -\partial_t \mathbf{B}$ . For uniqueness of  $\mathbf{A}$  and  $\varphi$ , we need a gauge condition. Because of numerical stability reasons [3], we choose the Lorenz gauging

$$\nabla \cdot \mathbf{A} + c\partial_t \varphi = 0 \quad (6)$$

with a suitable constant  $c$ . Using (5), the full Maxwell equations reduce to

$$\nabla \cdot (\varepsilon \nabla \varphi + \varepsilon \partial_t \mathbf{A}) = -\rho \quad (7)$$

$$\nabla \times (\nu \nabla \times \mathbf{A}) + \partial_t (\varepsilon \nabla \varphi + \varepsilon \partial_t \mathbf{A}) = \mathbf{J} \quad (8)$$

with  $\rho$  and  $\mathbf{J}$  given by (1) and (2) in which  $\mathbf{E}$  is replaced by  $-\nabla \varphi - \partial_t \mathbf{A}$ . Finally, a new variable, the pseudo-canonical momentum  $\Pi = \partial_t \mathbf{A}$  is introduced to avoid the second-order time derivative [7].

## 2 Lumped Circuit Equations

For lumped circuit models, the Kirchhoff's laws are satisfied and can be written as

$$\mathbf{A} \mathbf{i} = 0, \quad \mathbf{v} = \mathbf{A}^\top \mathbf{e} \quad (9)$$

with the incidence matrix  $A$  mapping branches to nodes of the circuit. The circuit variables are the vector  $\mathbf{i}$  of all branch currents, the vector  $\mathbf{v}$  of all branch

voltages and the vector  $\mathbf{e}$  of all nodal potentials. In contrast to the field variables, the circuit variables depend on time  $t$  only. Additionally, we have the constitutive element equations

$$\mathbf{i}_1 = \frac{d}{dt}q(\mathbf{v}_1, t) + g(\mathbf{v}_1, t), \quad \mathbf{v}_2 = \frac{d}{dt}\phi(\mathbf{i}_2, t) + r(\mathbf{i}_2, t)$$

for lumped current and voltage controlling elements, respectively. Notice, all basic types as capacitances, inductances, resistances and sources are covered by a suitable choice of the functions  $q$ ,  $g$ ,  $\phi$  and  $r$ .

Splitting the branches of the incidence matrix into  $A = (A_1, A_2, A_3)$  with respect to the current controlling, voltage controlling and electromagnetic field element models, the circuit equations can be written in the compact form of the Modified Nodal Analysis (MNA) as [6, 7]

$$A_1 \frac{d}{dt}q(A_1^\top \mathbf{e}, t) + A_1 g(A_1^\top \mathbf{e}, t) + A_2 \mathbf{i}_2 + A_3 \mathbf{i}_3 = 0 \quad (10)$$

$$\frac{d}{dt}\phi(\mathbf{i}_2, t) + r(\mathbf{i}_2, t) - A_2^\top \mathbf{e} = 0 \quad (11)$$

together with  $\mathbf{v}_3 = A_3^\top \mathbf{e}$ .

### 3 Interface Model

We assume the interface between the electromagnetic field model and the lumped circuit model to be perfectly electric conducting such that  $\mathbf{B} \cdot \mathbf{n}_\perp = 0$  and  $\mathbf{E} \cdot \mathbf{n}_\parallel = 0$  with  $\mathbf{n}_\perp$  and  $\mathbf{n}_\parallel$  being the outer unit normal vectors transversal and parallel to the contact boundary. This motivates the boundary conditions [3]

$$(\nabla \times \mathbf{A}) \cdot \mathbf{n}_\perp = 0, \quad (\nabla \phi) \cdot \mathbf{n}_\parallel = 0. \quad (12)$$

Denoting by  $\Gamma_k$  the  $k$ -th contact of the electromagnetic field model element with  $\Gamma_0$  being the reference contact and choosing any position  $x^k \in \Gamma_k$ , we obtain the coupling equations

$$\mathbf{i}_3^k = \int_{\Gamma_k} [\mathbf{J} - \partial_t(\epsilon(\nabla \phi + \Pi))] \cdot \mathbf{n}_\perp d\sigma$$

$$\mathbf{v}_3^k = \phi(x^k) - \phi(x^0)$$

that can be bundled as

$$\mathbf{i}_3 = B_J \mathbf{J} + B_\phi \partial_t \phi + B_\Pi \partial_t \Pi, \quad (13)$$

$$A_3^\top \mathbf{e} = R_\phi \phi. \quad (14)$$

with linear boundary operators  $B_J$ ,  $B_\phi$ ,  $B_\Pi$  and  $R_\phi$ .

### 4 Coupled Model Structure

Discretizing the electromagnetic field model in space by the FIT discretization as described in [2, 3] and using as time discretization the BDF methods for the resulting differential algebraic system as given in [5], we obtain a Jacobian structure of the form

$$J = \begin{pmatrix} J_E & J_{EB} & 0 \\ J_{BE} & I & J_{BC} \\ 0 & J_{CB} & J_C \end{pmatrix}$$

with a diagonally dominant matrix  $J_E$  for the electromagnetic and a positiv semidefinite matrix  $J_C$  for the lumped circuit part, respectively, if the time steps and mesh size are sufficiently small and if we take the variable order  $\varphi$ ,  $\mathbf{A}$ ,  $\mathbf{J}$ ,  $n$ ,  $p$ ,  $\mathbf{i}_3$ ,  $\mathbf{e}$ ,  $\mathbf{i}_2$  as well as the coupled equation system order (7), (8), (2), (3), (4), (13), (10), (11). Some details about  $J_C$  and  $J_E$  are given in [3, 4]. Important is here that we plug in the discretized versions of the equations (12), (14), (1), (6) and  $\Pi = \partial_t A$  before. It allows to combine an efficient iterative solver for the high dimensional (due to 3D discretization) matrix part  $J_E$  resolving  $\varphi$ ,  $\mathbf{A}$ ,  $\mathbf{J}$ ,  $n$ ,  $p$  with a simple evaluation process for the determination of the coupling current  $i_3$  and a direct solver for the elimination of the circuit variables  $\mathbf{e}$  and  $\mathbf{i}_2$  after use of a Schur complement approach.

*Acknowledgement.* We would like to thank Lennart Jansen, Peter Meuris, Sebastian Schöps and Bart De Smedt for valuable discussions. Part of this work was financially supported by the EU funded FP7 project nanoCOPS GA619166 and the German DFG research center MATHEON in Berlin.

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